

Fig. S1 UV-vis absorption spectra of TiO_2 via different concentration of MCA modification.

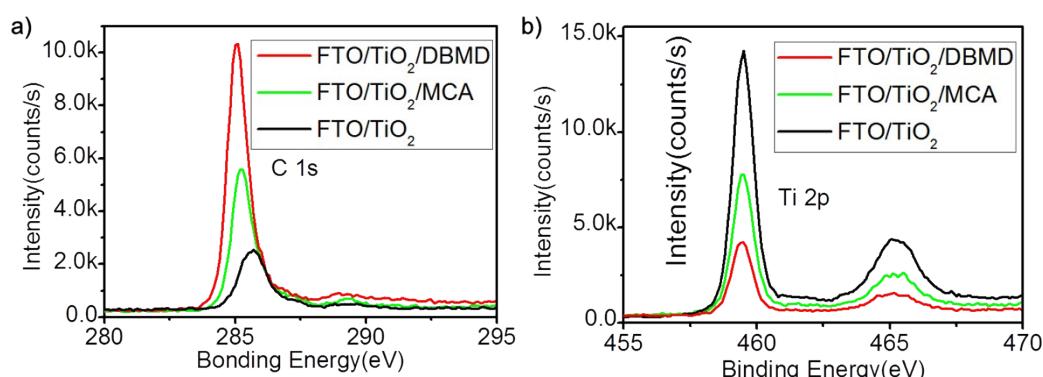


Fig. S2 Surface XPS analyses of a) carbon (285.0 eV (C1s)) and b) titanium (464.5 eV, $2\text{p}_{1/2}$, 458.8 eV, $2\text{p}_{3/2}$) from FTO/ TiO_2 and FTO/ TiO_2 /MCA substrates.

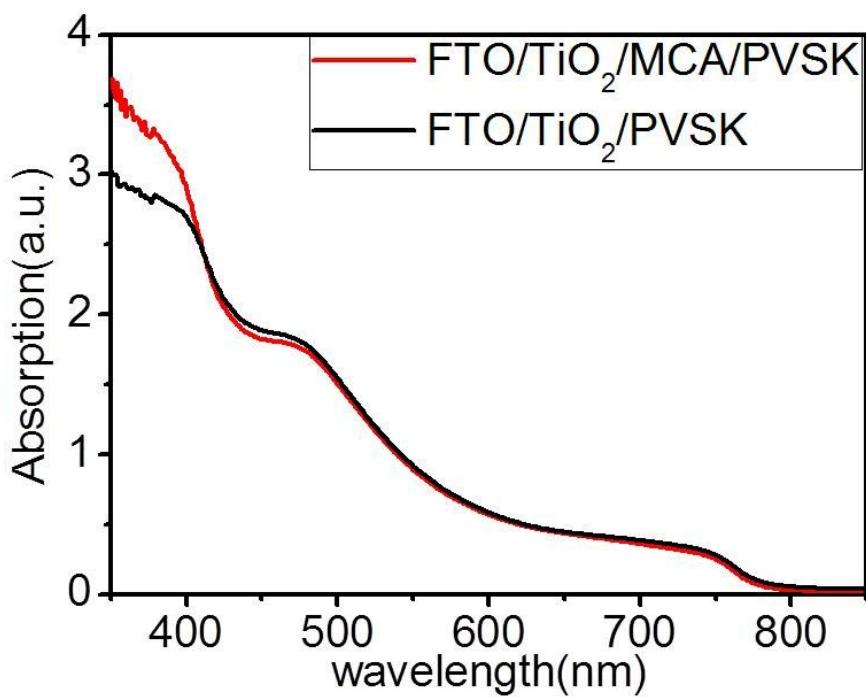


Fig. S3 Absorption spectra of perovskite film grown on TiO₂ and TiO₂/MCA.

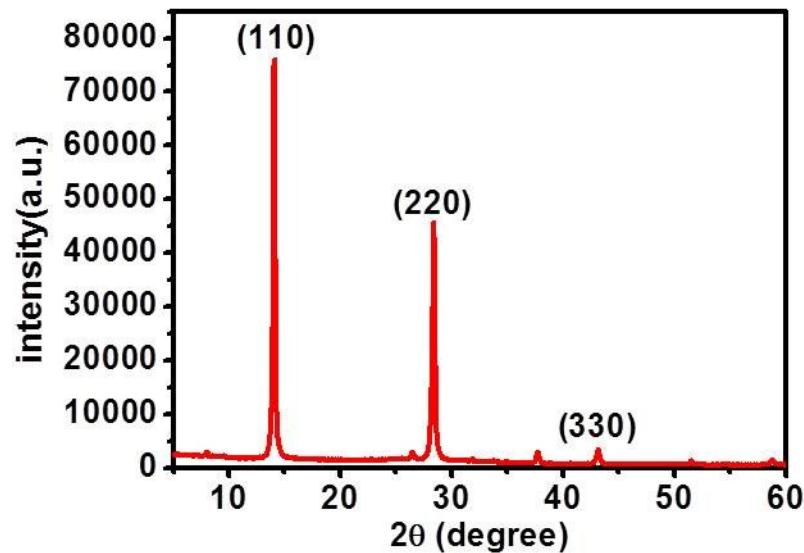


Fig. S4 XRD-pattern of the perovskite films grown on TiO₂ with MCA modification.

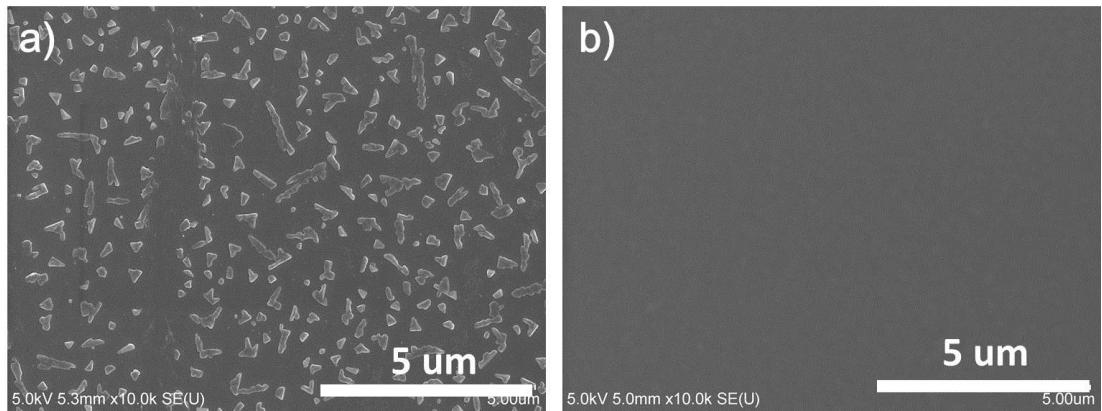


Fig. S5 SEM images of different substrate at the same scale a) FTO/ TiO₂, b) FTO/ TiO₂/MCA.

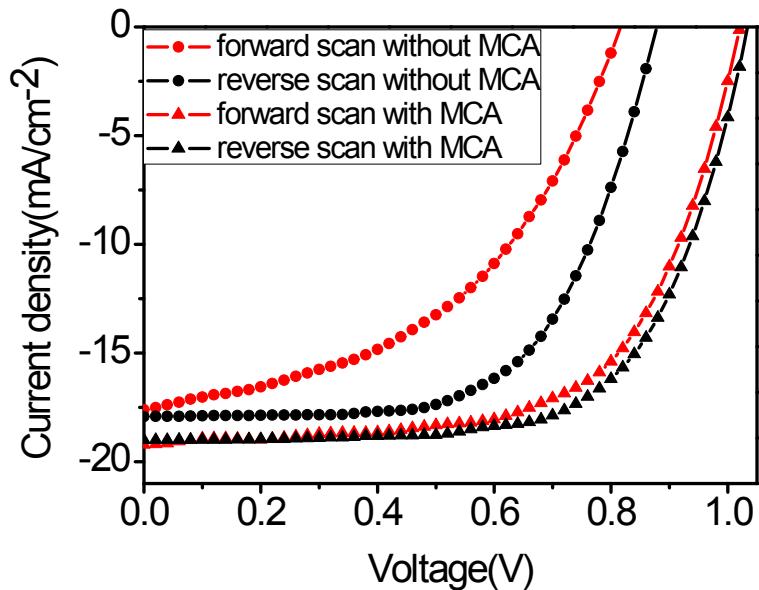


Fig. S6 *J-V* curves of larger active area cell from forward and reverse scan with and without MCA modification, with a delay time of 20 ms and a voltage step of 0.02 V s⁻¹.

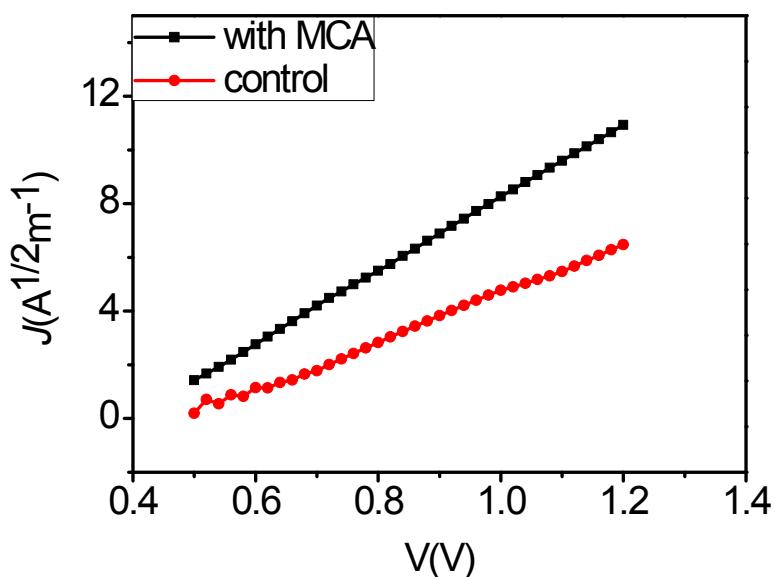


Fig. S7 J - V characteristics under dark for electron-only devices based on with and without MCA with the structure of FTO/ TiO₂/PVSK/PCBM/Ag.

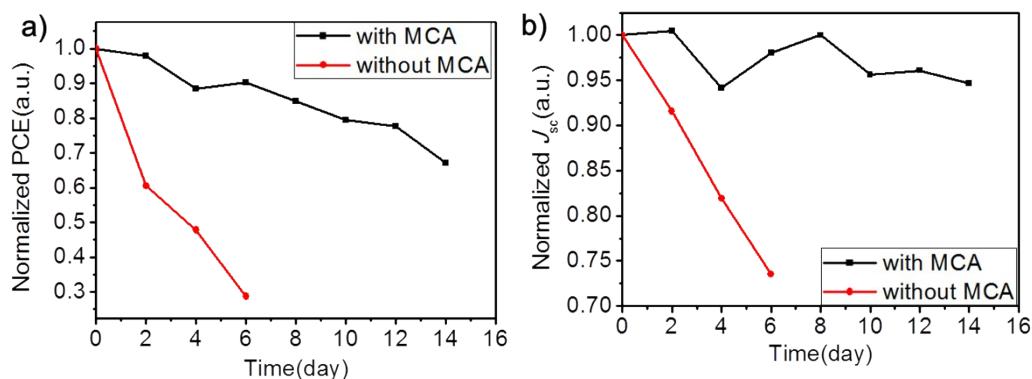


Fig. S8 Long-term stability tests of devices modified with MCA using forward scan mode.

Different concentrations of DBMB

Device	Voc(V)	Jsc(mA/cm2)	FF	PCE(%) Average
Control	0.987	12.5	26.59	3.29
	1.18	11.8	47.13	5.54
3mg/ml	0.988	19.3	43.81	8.35
	1.05	19.6	56.4	11.58
6mg/ml	1.09	19.7	64.60	13.85
	1.09	19.9	65.12	14.07
9mg/ml	1.16	18.3	66.66	14.14
	1.15	19.2	65.11	14.37
12mg/ml	1.07	18.9	59.78	12.16
	1.08	18.9	62.32	12.75

Table 1. Effect of MCA concentration on the performance of $\text{CH}_3\text{NH}_3\text{PbI}_3$ solar cells

Device	Voc(V)	Jsc(mA/cm2)	FF	PCE(%) Best
c-TiO ₂ (FS)	$0.81 \pm 0.01(0.82)$	$16.58 \pm 1.03(17.61)$	$49.21 \pm 2.43(46.78)$	$6.62 \pm 0.11(6.73)$
c-TiO ₂ (RS)	$0.83 \pm 0.05(0.80)$	$18.06 \pm 0.22(17.84)$	$55.28 \pm 7.66(62.94)$	$8.30 \pm 1.56(9.86)$
c-TiO ₂ /MCA(FS)	$1.02 \pm 0.03(1.05)$	$19.20 \pm 0.25(19.45)$	$63.20 \pm 2.03(61.17)$	$12.39 \pm 0.1(12.49)$
c-TiO ₂ /MCA(RS)	$1.03 \pm 0.04(1.07)$	$18.96 \pm 0.45(19.41)$	$66.15 \pm 1.19(64.96)$	$12.97 \pm 0.47(13.44)$

Table 2. The performance of the devices with larger active area.